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APPLICANTS

Tsutomu Sato, Yokohama-shi, JAPAN;

Hajime Nagano, Yokohama-shi, JAPAN;

Ichiro Mizushima, Yokohama-shi, JAPAN; Takashi Yamada, Ebina-shi, JAPAN;

Yuso Udo, Chofu-shi, JAPAN;

Shinichi Nitta, Yokohama-shi, JAPAN;

** CONTINUING DATA *****

This application is a DIV of 10/091,448 03/07/2002 PAT 6,630,714

** FOREIGN APPLICATIONS *****

JAPAN 2001-398184 12/27/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	4	12	3
Verified and Acknowledged	<u>N. M.</u> <u>N. J.</u> Examiner's Signature Initials				

ADDRESS

22850
 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.
 1940 DUKE STREET
 ALEXANDRIA, VA
 22314

TITLE

SEMICONDUCTOR DEVICE FORMED IN SEMICONDUCTOR LAYER ARRANGED ON SUBSTRATE WITH ONE OF INSULATING FILM AND CAVITY INTERPOSED BETWEEN THE SUBSTRATE AND THE SEMICONDUCTOR LAYER

 All Fees

FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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